



11-29-01

Gp/1711/18

Attorney Docket No. UMC-96-279 CON
Client/Matter No. 81848.0016.001

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Coming CHEN, et al

Serial No. 09/546,174

Filed: April 11, 2000

For: HIGH DENSITY PLASMA CHEMICAL
VAPOR DEPOSITION PROCESS

Examiner: 1711

Art Unit: R. SERGENT

#716/Ext
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Jan
12-27-01

PETITION FOR 2-MONTH EXTENSION OF TIME

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DEC 3 2001
TC 1700

Assistant Commissioner for Patents
2900 Crystal Drive
Arlington, VA 22202-3513

Sir:

The undersigned hereby petitions for a 2-month extension of time in which to respond to the Communication mailed September 11, 2001, in the above case, from October 11, 2001, to December 11, 2001. A check in the amount of \$400.00 is enclosed herewith. A full response, with possible further extension petition, will be forthcoming.

Respectfully submitted,

November 26, 2001

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